

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified)		AMAT/2981/ECORE/ CORE/MBE	09/220,153
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Reimer, et al.	Confirmation No. 3858
(Use several sheets if necessary)		Filing Date	Group
Examiner R. Bueker		December 23, 1998	1763

U.S. Patent Documents

Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						

COPY OF PAPERS
ORIGINALLY FILEDRECEIVED
MAR 20 2002
TC 1700

Foreign Patent Documents

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
RRB	B1	JP 2-184333 w/ English Abstract	07-18-1990	Japan	B01J	3/02		X
RRB	B2	JP 4-358531 w/ English Abstract	12-11-1992	Japan	B01J	3/02		X
RRB	B3	JP 6-29367	02-04-1994	Japan	H01L	21/58		X
RRB	B4	JP 7-167053 w/ English Abstract	07-04-1995	Japan	F04B	37/16		X
RRB	B5	JP 8-74041	03-19-1996	Japan	C23C	14/24		X
RRB	B6	JP 9-168732 w/ English Abstract	06-30-1997	Japan	B01J	3/02		X
RRB	B7	JP 9-251981 w/ English Abstract	09-22-1997	Japan	H01L	21/2065		X

OTHER ART

Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
Examiner	R Bueker	Date Considered 10-2003

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified)		AMAT/2981/IBSS/CP S/BG	09/220,153
INFORMATION DISCLOSURE STATEMENT BY APPLICATION		Applicant	Confirmation No.:
		Applied Materials, Inc.	3858
(Use several sheets if necessary)		Filing Date	Group
Examiner R. Beuker		December 23, 1998	1763

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
RRB	A1	5,944,049	08-31-1999	Beyer et al.	137	487.5	07-15-1997
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
	A13						

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
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	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
	C3	

Examiner <i>R Beuker</i>	Date Considered 10 - 2003
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Sheet 1 of 1 sheet(s)

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LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT				Applicant Applied Materials, Inc.		Confirmation No.: 3858	
(Use several sheets if necessary)				Filing Date December 23, 1998		Group 1763	
Examiner							
U.S. Patent Documents							
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1						
	A2						
	A3						
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	A5						
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	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
Foreign Patent Documents							
*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation
							YES NO
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	B2						<input type="checkbox"/> <input type="checkbox"/>
	B3						<input type="checkbox"/> <input type="checkbox"/>
	B4						<input type="checkbox"/> <input type="checkbox"/>
	B5						<input type="checkbox"/> <input type="checkbox"/>
OTHER ART							
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.					
R R B	C1	Various pages describing a Model IPX100 Dry Vacuum Pump and illustration showing the position of the pump relative to a semiconductor processing apparatus, 4 pps.					
	C2						
	C3						
Examiner <i>R. Buehler</i>				Date Considered 7-2002			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							

U.S. PENDING PATENT APPLICATION

ATTORNEY DOCKET NO.: 2981/USA/SMO/PJS
SERIAL NO.: N/A - FILED: HERewith
INVENTORS: REIMER, ET AL.

EXAMINER'S INITIALS		<u>PENDING U.S. PATENT APPLICATION(S)</u>
	AA	U.S. Patent Application entitled, "An Apparatus and Method for Regulating a pressure in a Chamber," filed _____; Serial No. _____; Inventors: Beyers, et al.
	AB	
	AC	
	AD	
	AE	
	AF	
	AG	
	AH	
	AI	
	AJ	

Richard B. Buhl 10-2003